



IFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80781

Takeyoshi KANO, et al.

Appln. No.: 10/828,472

Group Art Unit: 1774

Confirmation No.: 5352

Examiner: Tamra Dicus

Filed: April 21, 2004

For: PATTERN FORMING METHOD, IMAGE FORMING METHOD, FINE PARTICLE ADSORPTION PATTERN FORMING METHOD, CONDUCTIVE PATTERN FORMING METHOD, PATTERN FORMING MATERIAL AND PLANOGRAPHIC PRINTING PLATE

**LETTER OF CLARIFICATION**


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

On review of the Information Disclosure Statement and PTO/SB/08 A& B (modified) filed September 14, 2005, it is noted that "JP 59-101657" is listed on page 2 of the Information Disclosure Statement and on page 2 of the PTO/SB/08 A& B (modified) in error. Applicants apologize for the error and respectfully request that the Examiner disregard this entry.

Respectfully submitted,

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Date: November 20, 2006